



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 9442

KIRIMURA et al.

Art Unit: 1765

Application No.: 09/822,414

Examiner: M. Song

Filed: April 2, 2001

Attorney Dkt. No.: 107351-00011

For: FILM FORMING APPARATUS AND METHOD OF FORMING A CRYSTALLINE  
SILICON FILM

**AMENDMENT UNDER 37 CFR §1.111**

**Mail Stop: Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: January 18, 2005

Sir:

In reply to the outstanding Office Action dated October 18, 2004, please amend  
the application as shown on the following pages: